



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA

Batch/Confirmation No.: 4482

Allowed: August 19, 2002

Group Art Unit: 2851

Examiner: R. Fuller

Docket No.: 105193.01

Application No.: 09/697,639

Filed: October 27, 2000

For: EXPOSURE APPARATUS AND METHOD OF FABRICATING A MICRO
DEVICE USING THE EXPOSURE APPARATUS

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LETTER TO THE OFFICIAL DRAFTSPERSON

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Please substitute the attached 27 sheets of formal drawings depicting Figures 1-27 for the corresponding drawings filed with the application. The attached drawings have been corrected pursuant to the Examiner's comment in the Notice of Allowance (Paper No. 7).

Respectfully submitted,

Mario A. Costantino

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MAC/ccs

Date: September 18, 2002

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